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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Yasuji HIRAMATSU, et al.

SERIAL NO.: NEW U.S. PCT APPLICATION

FILED: HERewith

INTERNATIONAL APPLICATION NO.: PCT/JP01/06287

INTERNATIONAL FILING DATE: July 19, 2001

FOR: CERAMIC HEATER FOR A SEMICONDUCTOR PRODUCING/EXAMINING DEVICE,  
PROCESS OF PRODUCING THE CERAMIC HEATER, AND PRODUCTION SYSTEM OF THE  
CERAMIC HEATER**REQUEST FOR PRIORITY UNDER 35 U.S.C. 119**  
**AND THE INTERNATIONAL CONVENTION**Assistant Commissioner for Patents  
Washington, D.C. 20231*Yasuji*  
#5  
3/5/2003

Sir:

In the matter of the above-identified application for patent, notice is hereby given that  
the applicant claims as priority:**COUNTRY**  
Japan**APPLICATION NO**  
2000-219671**DAY/MONTH/YEAR**  
19 July 2000Certified copies of the corresponding Convention application(s) were submitted to the  
International Bureau in PCT Application No. PCT/JP01/06287. Receipt of the certified  
copy(s) by the International Bureau in a timely manner under PCT Rule 17.1(a) has been  
acknowledged as evidenced by the attached PCT/IB/304.Respectfully submitted,  
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